

Stanford

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Publications

PUBLICATIONS

- **Bottom-Up Fabrication of Oxygen Reduction Electrodes with Atomic Layer Deposition for High-Power-Density PEMFCs** *CELL REPORTS PHYSICAL SCIENCE*
Dull, S. M., Xu, S., Goh, T., Lee, D., Higgins, D., Orazov, M., Koshy, D. M., Vullum, P., Kirsch, S., Huebner, G., Torgersen, J., Jaramillo, T. F., Prinz, et al
2021; 2 (1)
- **A scalable bonding technique for the development of next-generation brain-machine interfaces**
Wang, P., Goh, T., Hemed, N., Melosh, N., IEEE
IEEE.2019: 863–66